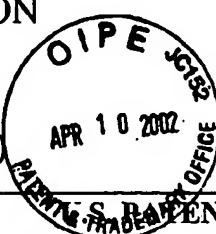


INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)			ATTY. DOCKET NO. 50395-131	SERIAL NO. 10/051,023		
APPLICANT Kenichi KURISU, et al.						
FILING DATE January 22, 2002			GROUP 1746			
U.S. PATENT DOCUMENTS						
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	
FOREIGN PATENT DOCUMENTS						
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation
						Yes
<i>TA</i>	0 629 592 A	12/21/1994	EPO			<input checked="" type="checkbox"/>
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)						
<i>TA</i>	W. Walecki, W. Patterson, A. Nurmikko, H. Luo, N. Samarth, J. Furdyna, M. Kobayashi, S. Durbin, and R. Gunshor, "Ultraviolet and Blue Holographic Lithography of ZnSe Epilayers and Heterostructures with Feature Size to 100 nm and Below," <i>Applied Physics Letters</i> , 57, No. 25, December 1990, pp. 2641-2643.					
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EXAMINER <i>FAYEZ ASAF</i>	DATE CONSIDERED <i>3/3/04</i>					

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 			APPLICANT Kenichi KURISU, et al.	TECHNOLOGY CENTER 1700 APR 11 2002		
(PTO-1449)			FILING DATE January 22, 2002		GROUP 1746	
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						TC 1700
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EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation
TA	2000-280225	10/10/2000	Japanese(w/English Abstract)	-----	-----	Yes
TA	2000-280226	10/10/2000	Japanese(w/English Abstract)	-----	-----	No
TA	10-300912	11/13/1998	Japanese(w/English Abstract)	-----	-----	
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)						
EXAMINER	DATE CONSIDERED			3/4/04		
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